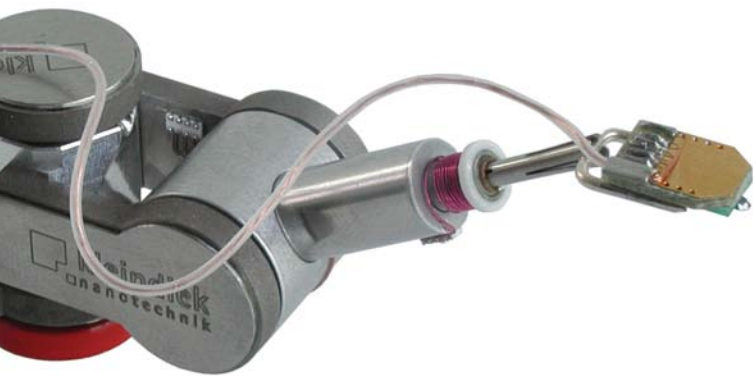


FMS-EM Force Measurement System

The FMS-EM is a compact force readout tool for the MM3A-EM micromanipulator. It enhances your system by allowing you to perform force measurements and nanoindentation.



Smallest outer dimensions are possible by means of a force readout system that requires no laser. Force feedback on the display of the FMS-EM controller is coupled with a loudspeaker to enable you to intuitively characterize materials and micromechanical structures by their resonance frequencies. Sharp silicon tips allow nanoindentation in a wide variety of materials.

The plug-in tool be quickly and easily fitted to your existing MM3A-EM micromanipulator.

Applications

- Nanoindentation
- Tensile measurement
- MEMS analysis

Technical specifications FMT-400 sensors

- Length 400 μm
- Width 50 μm
- Height 4 to 5 μm
- Tip radius < 20 nm
- Tip height > 5 μm
- Tip force constant (calculation) 2 to 4 N/m
- Maximum tip force 80 μN ¹
- Resistance 500 to 650 Ω
- Sensitivity 3.1×10^{-3} mV/nm at $V_{\text{bridge}} = 2.5 \text{ V}$ ²
- Lowest pressure 10^{-7} mbar

Technical specifications FMT-120 sensors

- Length 120 μm
- Width 50 μm
- Height 4 to 5 μm
- Tip radius < 20 nm
- Tip height > 5 μm
- Tip force constant (calculation) 30 to 40 N/m
- Maximum tip force 360 μN ¹
- Resistance 500 to 650 Ω
- Sensitivity 18.8×10^{-3} mV/nm at $V_{\text{bridge}} = 2.5 \text{ V}$ ²
- Lowest pressure 10^{-7} mbar

¹ Calculated with assumptive deflection of 10% and the lowest force constant

² Dependent on the bias voltage (V_{bridge}) that is applied to the series resistance of sensor and reference

Further information

- Contact us at info@nanotechnik.com
- Find your local agent at www.nanotechnik.com

